



JFW

Docket Number: 061063-0356139
Client Reference: OSP-19398

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

MASATAKA HOURAI

Group Art Unit: 1722

Application No.: 10/587,039

Examiner: HITESHEW, F.

Filed: July 24, 2006

Confirmation No.: 2722

For: SILICON WAFER, METHOD FOR MANUFACTURING THE SAME AND METHOD FOR GROWING SILICON SINGLE CRYSTALS

RESUBMISSION INFORMATION DISCLOSURE STATEMENT CORRECTING PTO-1449

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Copies of cited U.S. patents and patent application publications are not included. Copies of foreign patent documents and non-patent literature are included. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference has been considered, per MPEP § 609.

Applicants respectfully note this Information Disclosure Statement is being submitted to correct an error in the PTO-1449 form previously submitted in an Information Disclosure Statement on August 1, 2007. It should be noted 2001-0090002 cited on the PTO-1449 should read --Korea-- not "Japan". We are hereby submitting a corrected PTO-1449 with the reference listed correctly. Please make the necessary change in the record of file.

It is not believed that any fees are required with this submission. However, if necessary, please charge any fees associated with the submission of this papers to Deposit Account No. 033975.

Respectfully Submitted,
PILLSBURY WINTHROP SHAW PITTMAN LLP

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FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office



Atty. Dkt. No.	M#	Client Ref.
061063	0356139	OSP-19398
Applicant: HOURAI et al.		
Appln. No.: 10/587,039		
Filing Date: July 24, 2006		
Examiner: HITESH, F. Group Art Unit: 1722		

Date: September 5, 2007

Page **1** of **1**

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	2003/0022003 A1	01/30/2003	Park			
BR						
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

FOREIGN PATENT DOCUMENTS						English Abstract		Translation Readily Available	
	Document Number	Date MM/YYYY	Country	Inventor Name		Enclosed	No	Enclose	No
OR	2001-0090002	10/17/2001	Korea			X			
PR	486749	05/11/2002	Taiwan			X			
QR									
RR									
SR									
TR									
UR									
VR									
WR									
XR									

OTHER (Including in this order: Author, Title, Periodical Name, Date, Pertinent Pages, etc.)									
YR	Office Action dated May 2, 2007 on the counterpart Taiwanese Patent Application No. 094128981.								X
ZR									
AAR									
BBR									

Examiner _____ Date Considered: _____

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.